



DE-16 Camera System

ultra high speed direct detection for in situ TEM

Direct Electron delivers | bigger | better | faster | cameras for electron microscopy

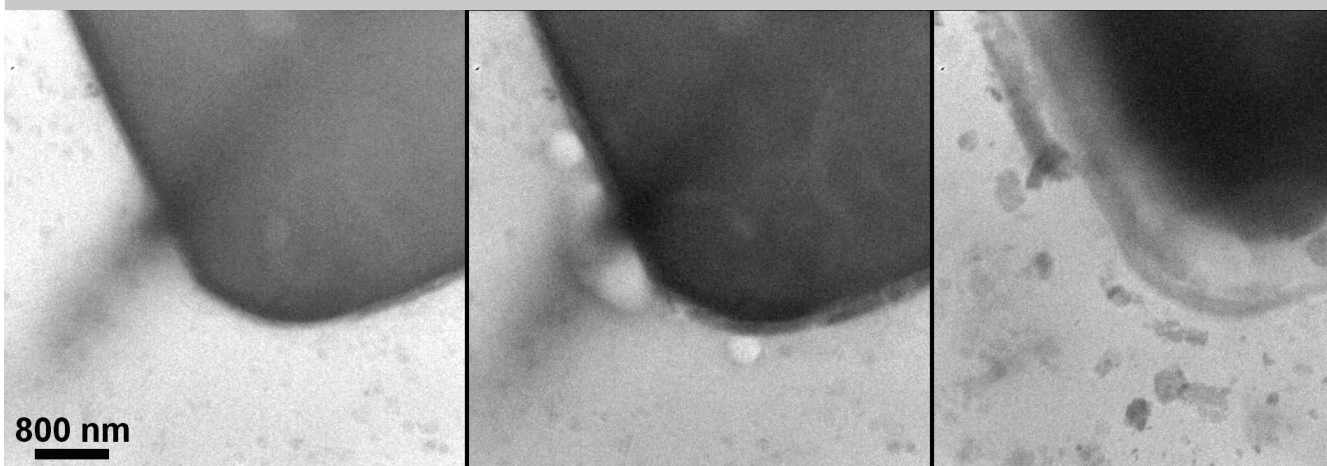
Better Science, Faster – Brilliant Results in Less Time

- Direct detection device (DDD®) delivers *high resolution, excellent sensitivity, and ultra-low noise.*
- **4k × 4k** (16.8 million) pixels.
- Ideal for materials science with the best dynamic range of any direct detector.
- *High-speed* continuous streaming for *in situ* TEM and “movie-mode” processing (motion correction).
- *Unrivalled features*, such as an integrated survey sensor, Faraday plate, and open-source software.
- *Electron counting* to maximize signal-to-noise ratio, when needed.
- *The best of all the new TEM camera technology in a single integrated system.*
- Low total cost-of-ownership and exceptional support.

Microscopy
TODAY
INNOVATION AWARDS



In situ TEM experiment with an electrochemical liquid cell, showing dissolution of an electrode. Data was collected at 75 frames per second (fps). Courtesy of Haimei Zheng, Lawrence Berkeley National Lab. Published in Zeng, et al., *Faraday Discuss* 176 (2014).



800 nm

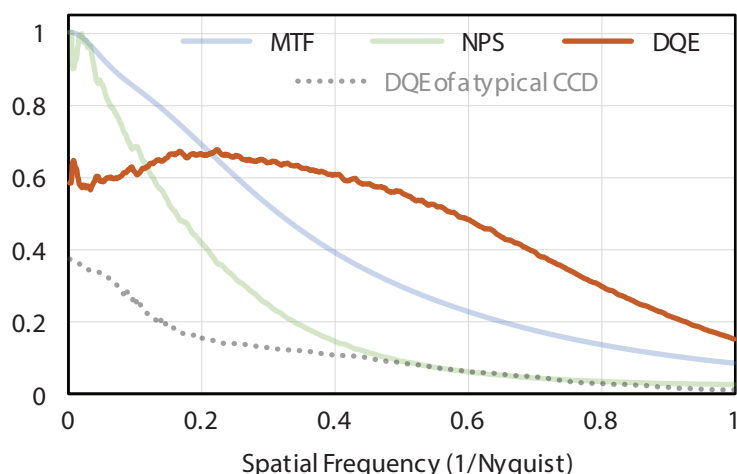
Direct Electron®
INNOVATION PROPELLING DISCOVERY

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detection electron energy	optimized for 80 keV – 1.25 MeV
pixel array specification	4096 × 4096 (16.8 million pixels) 6.5 μm pixel pitch
single electron SNR	~50:1 (300 kV)
sensor design	>3T pixel design with correlated double sampling (CDS) backthinned radiation hardened
acquisition frame rate	60 fps max, unbinned full-frame 120 fps, bin 2× full-frame subarray readout up to 1920 fps max
acquisition modes	integrating mode counting mode (with optional counting system)
exposure rate	large dynamic range with consistent performance in integrating mode (e.g., 4 – 800 e-/pixel/s)
mounting position	fully retractable mounted on-axis TEM bottom port or in JEOL film drawer
"buddy" camera	integrated near-axis 2048 × 2048 scintillator-coupled survey sensor
exposure measurement	integrated Faraday plate for exposure measurement with each acquisition
sensor protection	integrated physical protection shutter microscope blanking/shuttering failsafe software
computer system	certified high-performance computer system with large >25 TB RAID array for data streaming
image format	image data stored in non-proprietary format to ensure broad compatibility
acquisition & processing software	conventional acquisition: DE-IM (full-featured, user-friendly) μManager (free, open-source) in situ movie acquisition: DE-StreamPix (continuous streaming) automated acquisition: Leginon SerialEM EMTools (TVIPS) others using the DE SDK "movie" processing: DE image processing software (free, open-source, Python-based) others customization: software development kit (SDK) for integration with custom software

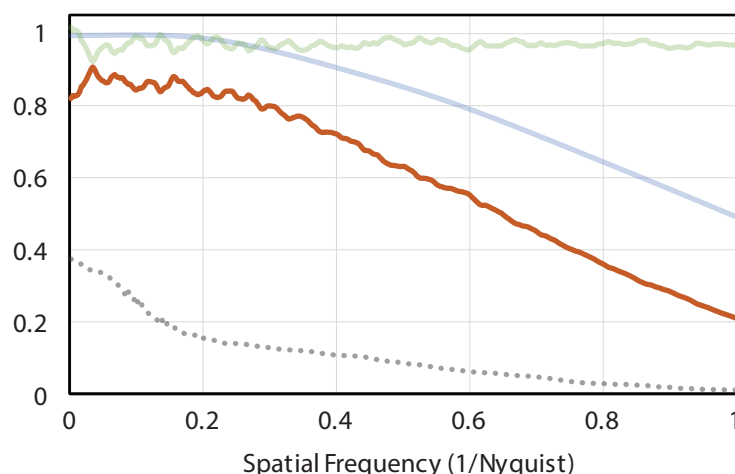
Integrating Mode

best for maximizing overall productivity



Electron Counting Mode

best for maximizing signal-to-noise ratio



* Note: Specifications and performance are subject to change.



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